Continuous Gas Analyzers, in-situ

LDS 6

Overview

LDS 6 is a diode laser gas analyzer with a measuring principle based on the specific light absorption of different gas components. LDS 6 is suitable for fast and non-contact measurement of gas concentrations or temperatures in process or flue gases. One or two signals from up to three measuring points are processed simultaneously by the central analyzer unit. The in-situ cross-duct sensors at each measuring point can be separated up to 700 m from the central unit by using fiber-optic cables. The sensors are designed for operation under harsh environmental conditions and contain a minimum of electrical components.

Benefits

The in-situ gas analyzer LDS 6 is characterized by a high availability and unique analytical selectivity, and is optimally suitable for numerous applications. LDS 6 enables the measurement of one or two gas components or - if desired - the gas temperature directly in the process:

- With high dust load
- In hot, humid, corrosive, explosive, or toxic gases
- In applications showing strong varying gas compositions
- Under harsh environmental conditions at the measuring point
- Highly selective, i.e. mostly without cross-sensitivities

LDS 6 properties:

- Little installation effort
- Minimum maintenance requirements
- Extremely rugged design
- High long-term stability through built-in, maintenance-free reference gas cell, field calibration is unnecessary
- Real-time measurements

Moreover, the instrument provides warning and failure messages upon:

- Need for maintenance
  - Erroneous reference function
  - Bad signal quality
- Violation of a lower or upper alarm level for the measured variable
- Transmitted amount of light violating an upper or lower limit

Application

Applications

- Process optimization
- Continuous emission monitoring for all kinds of fuels (oil, gas, coal, and others)
- Process measurements in power utilities and any kind of incinerator
- Process control
- Explosion protection
- Measurements in corrosive and toxic gases
- Quality control
- Environmental protection
- Plant and operator safety

Sectors

- Power plants
- Steel works
- Cement industry
- Chemical and petrochemical plants
- Automotive industry
- Waste incinerators
- Glass and ceramics production
- Research and development

Special applications

In addition to the standard applications, special applications are available upon request.
Continuous Gas Analyzers, in-situ

LDS 6

General information

**Design**

The gas analyzer LDS 6 consists of a central unit and up to three in-situ sensors. The connection between the central unit and the sensors is established by a so-called hybrid cable, which contains optical fibers and copper wires. An additional cable connects the transmitter and receiver parts of the cross-duct sensor.

**Central unit**

The central unit is housed in a 19” rack unit enclosure with 4 holders for mounting
- in a hinged frame
- in racks with or without telescopic rails

**Display and control panel**

- Large LCD field for simultaneous display of measurement result and device status
- Contrast of the LCD field is adjustable via the menu
- LED background illumination of the display with energy-saving function
- Easy-to-clean membrane touch pad with softkeys
- Menu-driven operation for parameterization and diagnostics
- Operation support in plain text

**Input and outputs**

- One to three measurement channels with hybrid connections for the sensors at the measuring points
- 2 analog inputs per channel for process gas temperature and pressure
- 2 analog outputs per channel for gas concentration(s) or for gas temperature and concentration. For selected versions, the transmission can be read out as an alternative.
- 6 freely configurable binary inputs per channel for signaling faults or maintenance requests from external temperature or pressure transducers or sensor purging failure.
- 6 freely configurable binary outputs per channel (signaling of fault, maintenance requirements, function control, transmission limit alarm, concentration limit alarm, store analog output)

**Communication**

Network connection: Ethernet (T-Base-10) for remote diagnostics and maintenance.

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LED-backlit graphic display and membrane tactile-touch keyboard

Status line to indicate the device status

Two code levels according to NAMUR

Menu-driven operator control with five softkeys

Numeric display of concentrations

ESC key to cancel entries

INFO key for help in plain text

Numeric keypad for entering digits

CLEAR key to delete the digits entered

ENTER key to adopt the numbers

MEAS key to return direct to measurement mode

LDS 6 central unit, membrane keyboard and graphic display
**Cross-duct sensors**

Sensor CD 6, transmitter or detector unit

- In-situ cross-duct sensors, configured as transmitter and detector unit, connected via sensor cable
- Connection to the LDS 6 central unit by a so-called hybrid cable, max. length 700 m
- Stainless steel, some painted aluminum
- IP65 degree of protection for sensor
- Adjustable flanges with flange connection
- DN 65/PN 6, ANSI 4”/150 lbs
- Optional flameproof window flanges with dimensions: DN 65/PN 6, DN 80/PN 16, ANSI 4”/150 lbs, other process interfaces available on request
- Purging facilities on the process and the sensor sides, configurable application with purging gas connections for:
  - Instrument air
  - Purging air blower
  - Steam
  - Nitrogen
  - Process gases to which the pressure equipment directive cat. 2 does not apply
- In combination with high-pressure window flanges, purging with instrument air or nitrogen is possible
- Fast connectors for cleaning the measurement openings and the sensor window
- Optional: Version with explosion protection in accordance with ATEX / IEC Ex ia
- Sensor type CD 6 is compliant with the pressure equipment directive

**Parts in contact with the process gas**

The sensors normally do not come into contact with the process gas, since purging with a gaseous media is applied at the process side. Stainless steel purging gas tubes in front of the sensor windows immerse slightly into the process gas and thus limit the purging volume. Special materials such as Hastelloy, plastics (PP) and ceramics are available on request.

**Hybrid and sensor cables**

A combination of fiber-optic cables and twisted copper wires connects the sensors to the central unit. The hybrid cable connects the central unit with the detector unit of the sensor, the sensor cable connects the transmitter and receiver units of the sensor.

For installation in Ex-protected environments, the legislative regulations have to be complied with, such as the spatial separation of intrinsically-safe from non-intrinsically-safe cables.

In compliance with standard EN IEC 60079-14, systems with intrinsically-safe circuits must be installed such that their intrinsic safety is not impaired by electric or magnetic fields. Therefore the hybrid and sensor cables of the LDS 6 in an Ex application must be routed in such a way that they cannot generate electric or magnetic fields, e.g. by coiling them in more than one cable loop. To guarantee a good signal quality and to avoid impermissible inductance loops, the hybrid and sensor cables should be kept as short as possible.

- The distance between central unit and measuring point can be
  - up to 250 m for Ex units when used in Zone 0 and Zone 1
  - up to 700 m for Ex units used in Zone 2 and for non-Ex units
- Hybrid and sensor cables
  - Multimode fiber-optic cable, provided with SMA connections for transmission of the measured signal
  - Two-wire copper cable, in twisted pair version, for +24 V supply of the detector electronics (+12 V in the case of Ex-suitable instruments)
  - Single-mode fiber-optic cable, configured double-sided with E2000 connectors for transmission of laser light
- Rugged cable sheath for laying in open cable ducts or ducts
- Sheath material: oil-resistant polyurethane

**Connections of the hybrid cable**
Continuous Gas Analyzers, in-situ

General information

**Function**

**Operating principle**

LDS 6 is a gas analyzer employing single-line molecular absorption spectroscopy. A diode laser emits a beam of near-infrared light, which passes through the process gas and is detected by a receiver unit. The wavelength of the laser diode output is tuned to a gas-specific absorption line. The laser continuously scans this single absorption line with a very high spectral resolution.

The result is a fully resolved single molecular line which is analyzed in terms of absorption strength and line shape. The influence of cross-sensitivities on the measurement is negligible, since the quasi-monochromatic laser light is absorbed very selectively by only one specific molecular line in the scanned spectral range.

![Diagram of LDS 6 configuration](image)

**Basic design of the LDS 6**

**Configuration examples:**

A feature of the in-situ analytical procedure is that the physical measurement takes place directly in the stream of process gas, and usually also directly in the actual process gas line. All process parameters such as gas matrix, pressure, temperature, moisture, dust load, flow velocity and mounting orientation can influence the measuring properties of the LDS 6 and must therefore be systematically investigated for each new application.

A feature of the standard applications defined in the ordering data of the LDS 6 is that the typical process conditions are well-known and documented, and that the guaranteed measuring properties can be proven by reference installations. If you cannot find your application among the standard applications, please contact Siemens. We will be pleased to check your possible individual application of the LDS 6. You can find an application questionnaire on the LDS product sites on the Internet.

![Typical transmitted light setup of LDS 6, in-situ](image)

To avoid contamination of sensor openings on the process side, clean gaseous purging media are used such as instrument air, N₂ or steam. Purging air tubes on the sensor heads, which slightly penetrate into the process gas stream, define the effective measuring path length.
The LDS 6 can measure in both the transverse and longitudinal directions of the process gas flow. In certain cases, the process conditions make it necessary to condition the sample gas stream in a bypass line with respect to process temperature, pressure and/or optical path length. Further treatment of the process gas, such as drying or dust precipitation, is usually unnecessary.

Typical transmitted light setup of LDS 6, in bypass

A flow cell is available by special application for the LDS 6 which has been specially optimized for use with the LDS 6 and its transmitted-light sensors with respect to handling and measuring performance. It is designed to reduce surface effects, and is therefore also highly suitable for polar gases like ammonia. This flow cell is available in heated and non-heated versions. Wheel mounted and wall mounted versions are available.

Measuring configuration of LDS 6 with heated flow cell

**General information**

LDS 6 is connected to the measuring points by fiber optics. The laser light is guided by a single-mode fiber from the central unit to the transmitter unit of the in-situ sensor. The sensor consists of a transmitter and a receiver; the distance between them defines the measurement path. In the receiver box, the light is focused onto a suitable detector. The detector signal is then converted into an optical signal and transmitted via a second optical fiber to the central unit, where the concentration of the gas component is determined from the detected absorption signal.

LDS 6 usually measures a single gas component by means of the absorption capacity of a single fully resolved molecular absorption line. The absorption results from conversion of the radiation energy of the laser light into the internal energy of the molecule. In the working range of the LDS 6, both rotation-vibration transitions and electronic transitions - such as with O₂ - can be triggered.

In some specific cases, two components can be measured simultaneously if their absorption lines are so close to each other that they can be detected within the laser spectrum by one single scan (for example water (H₂O) and ammonia (NH₃)).

Typical spectral bandwidth of an absorption line compared to the bandwidth of the laser light.

Typical measurable gases for LDS 6 are:
- Oxygen (O₂) for low and high pressure
- Oxygen + temperature
- Hydrogen fluoride (HF) + water
- Hydrogen chloride (HCl) + water
- Ammonia (NH₃) + water
- Water vapor (H₂O)
- Carbon monoxide (CO)
- Carbon dioxide (CO₂)
- CO + CO₂

By using an internal reference cell normally filled with the gas measured, the stability of the spectrometer is permanently checked in a reference channel.

By doing so, the continuous validity of the calibration is ensured without the need to carry out external recalibration using bottled calibration gases or reference gas cells.
### Influences on the measurement

#### Dust load

As long as the laser beam is able to generate a suitable detector signal, the dust load of the process gases does not influence the analytical result. By applying a dynamic background correction, measurements can be carried out without any negative impact.

Under good conditions, particle densities up to 100 g/Nm² can be handled by the LDS 6. Varying dust loads are compensated by scanning the laser over the gas absorption line and the current background. At a scan position next to the absorption line, the instrument can “see” only absorption caused by the dust load where at the line center the signal is composed of the molecular absorption and the continuous, unspecific background absorption. With the wavelength modulation technique, the actual measurement transmission is always compared with the baseline. After signal processing, phase-sensitive application delivers a signal only from the molecular line free of background.

The influence of a high dust load is complex and depends on the path length and particle size. The optical damping increases at longer path lengths. Smaller particles also have a large influence on the optical damping. With a combination of high dust load, long path length and small particle size, the technical support at Siemens should be consulted.

#### Temperature

The temperature influence on the absorption line strength is compensated by a correction factor determined during calibration. A temperature signal can be fed into the instrument from an external temperature sensor. This signal is then used to correct the influence of the temperature on the observed line strength. If the temperature of the sample gas remains constant, it is alternatively possible to carry out a static correction using a preset value.

At high process gas temperatures, generally from approximately 1000 °C, there may be noticeable broadband IR radiation of gas and dust, or flames may occasionally occur in the measurement path. An additional optical bandpass filter can be set upstream of the detector to protect it and prevent saturation by the strong background radiation.

#### Pressure

The gas pressure can affect the line shape of the molecular absorption line. LDS 6 uses a special algorithm to adapt the line shape. Additionally, an external pressure signal can be fed to the instrument to provide complete compensation for the pressure influence including the density effect.

#### Cross-interferences

Since LDS 6 derives its signal from a single fully resolved molecular absorption line, cross-interferences with other gases are quite unlikely. LDS 6 is therefore able to measure the desired gas components very selectively. In special cases, the composition of the process gas might have an influence on the shape of the absorption line features. This influence is compensated by analyzing the full shape of the detected signal curve applying specific algorithms.

#### Optical path length

The absorption values analyzed by the LDS 6 are typically small. As a result of Beer-Lambert’s law, the absorption of laser light depends on the optical path length within the gas. Therefore, the precision in determining the effective optical path length in the process might limit the overall precision of the measurement.

As the sensor openings toward the process normally need to be purged to keep them clean over a long period of time, the thickness of the mixing zone between the purging medium and the process gas and its concentration distribution need to be considered. In a typical in-situ installation directly in the line and with some meters of path, the influence of the purging gas on the effective path length can be neglected.

Path length and dust load are mutually influencing: the higher the dust load in the process, the shorter the max. possible path length.

### Essential characteristics

- Integrated calibration adjustment with an internal reference cell
- Negligible long-term drifts of zero and span
- Dynamic background correction for varying dust loads
- Isolated signal outputs, 4 to 20 mA
- User-friendly, menu-driven operation
- Selectable time constants (response time)
- Two user levels with individual access codes for prevention of unwanted and unauthorized operations
- Operation according to NAMUR recommendations
- Monitoring of overall optical transmission
- Remote preventive maintenance and servicing via Ethernet/modem
- Straightforward replacement of the central unit, since connections can easily be removed
- Sensor and central unit housing free of wear and corrosion
- Easy operation with a numerical keypad and menu prompting

### Maintenance and fault messages

LDS 6 outputs different warnings via relays:

- Need for maintenance (measured value is not influenced)
- Operating error (measured value might be influenced)

Note

Individual requirements for the measuring point can make the utilization of special sensor equipment necessary. The possibilities for adapting the sensors are:

- Different purging media, such as instrument air, ambient air, nitrogen or steam
- Different purging modes on process and sensor sides
- Special materials of purging tubes and/or sensor flanges
- Cooling or heating of the sensors
- Explosion-protected sensor configurations
Certified versions for emission monitoring

The LDS 6 is available as certified instrument for emission monitoring of NH₃, NH₃/H₂O, H₂O, HCl, HCl/H₂O. The certificates are issued by TÜV for Germany and MCERTS for the United Kingdom. For conducting regular calibration and linearity checks, test kits for ammonia, water and HCl should be used. These kits can be ordered separately as instrument accessories. For new analyzer orders, the NH₃, NH₃/H₂O and H₂O kits named “Version 2” must be ordered. For already installed analyzers, please contact Siemens for spotting the correct kit version, or consult the instrument manual.

Verification of calibration

Assembly with certified, maintenance-free calibration gas cell with connections for laser fiber-optic conductors and detector module of cross-duct sensor. Serves to rapidly verify the factory calibration in the field without compressed gas bottles and flow cell.

Calibration verification kits are available for the following sample gases: O₂ (application codes AA, AC, AD), NH₃, CO, CO₂, CO/CO₂. A “Zero gas test kit” is also available (see "Additional units"").

Example of an assembly for verification of calibration
## Technical specifications

### Analytical performance

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Specification</th>
</tr>
</thead>
<tbody>
<tr>
<td>Measuring range</td>
<td>Adjustable</td>
</tr>
<tr>
<td>Detection limit (DL):</td>
<td>Depending on sample gas component; see table for standard applications.</td>
</tr>
<tr>
<td>Calculated in accordance with VDI 2449, measured on every supplied analyzer during the temperature test (between 5 ... 45 °C) in accordance with VDI 4203.</td>
<td></td>
</tr>
<tr>
<td>Smallest recommended measuring range (with 1 m path length)</td>
<td>Depending on sample gas component; see table for standard applications.</td>
</tr>
</tbody>
</table>

The maximum applicable measuring ranges can be found in the table of standard combinations. These can only be applied if the individual process conditions allow it. Please contact the Technical Support from Siemens for checking the applicability.

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Specification</th>
</tr>
</thead>
<tbody>
<tr>
<td>Accuracy</td>
<td>2 % / 5 %, depending on sample gas component and application letter. At best: detection limit. See table for standard applications. For Code ET and FT: in accordance with the requirements of 17th and 27th BImSchV</td>
</tr>
<tr>
<td>Linearity</td>
<td>Better than 1 %</td>
</tr>
<tr>
<td>Repeatability</td>
<td>2 % of the measured value or minimum detection limit (whichever is largest)</td>
</tr>
<tr>
<td>Calibration interval</td>
<td>No recalibration required thanks to internal reference cell</td>
</tr>
</tbody>
</table>

### Electrical characteristics

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Specification</th>
</tr>
</thead>
<tbody>
<tr>
<td>Power supply</td>
<td>100 ... 240 V, AC 50 ... 60 Hz, automatically adapted by the system; with a 3-channel central unit, an additional external power supply +24 V DC, 50 VA is included in the scope of delivery</td>
</tr>
<tr>
<td>Power consumption</td>
<td>50 W</td>
</tr>
<tr>
<td>EMC</td>
<td>According to EN 61326 and standard classification of NAMUR NE21</td>
</tr>
<tr>
<td>Electrical safety</td>
<td>According to EN 61010-1, overvoltage classification II</td>
</tr>
<tr>
<td>Fuse specifications</td>
<td>100 ... 240 V: T2.5L250V</td>
</tr>
</tbody>
</table>

### Dynamic response

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Specification</th>
</tr>
</thead>
<tbody>
<tr>
<td>Warm-up time at 20 °C ambient temperature</td>
<td>Approx. 15 min</td>
</tr>
<tr>
<td>Response time</td>
<td>Less than 3 s, application-dependent</td>
</tr>
<tr>
<td>Integration time</td>
<td>1 ... 100 s, adjustable</td>
</tr>
</tbody>
</table>

### Influencing variables

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Specification</th>
</tr>
</thead>
<tbody>
<tr>
<td>Ambient temperature</td>
<td>&lt; 0.5 %/10 K of the measured value</td>
</tr>
<tr>
<td>Atmospheric pressure</td>
<td>Negligible</td>
</tr>
<tr>
<td>Process gas pressure compensation</td>
<td>Recommended</td>
</tr>
<tr>
<td>Process gas pressure range</td>
<td>See table for standard applications</td>
</tr>
<tr>
<td>Power supply changes</td>
<td>&lt; 1 %/30 V</td>
</tr>
</tbody>
</table>

### Electrical inputs and outputs

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Specification</th>
</tr>
</thead>
<tbody>
<tr>
<td>Number of measurement channels</td>
<td>1 … 3, optional</td>
</tr>
<tr>
<td>Analog output</td>
<td>2 per channel, 4 ... 20 mA, floating, ohmic resistance max. 750 Ω</td>
</tr>
<tr>
<td>Analog inputs</td>
<td>2 per channel, designed for 4 ... 20 mA, 50 Ω</td>
</tr>
<tr>
<td>Binary outputs</td>
<td>6 per channel, with changeover contacts, configurable, 24 V AC/DC/1 A, floating</td>
</tr>
<tr>
<td>Binary inputs</td>
<td>6 per channel, designed for 24 V, floating, configurable</td>
</tr>
<tr>
<td>Communication interface</td>
<td>Ethernet 10BaseT (RJ-45)</td>
</tr>
</tbody>
</table>

### Climatic conditions

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Specification</th>
</tr>
</thead>
<tbody>
<tr>
<td>Temperature range</td>
<td>5 ... 45 °C during operation, -40 ... +70 °C during storage and transportation</td>
</tr>
<tr>
<td>Atmospheric pressure</td>
<td>800 ... 1 200 hPa</td>
</tr>
<tr>
<td>Humidity</td>
<td>&lt; 85 % relative humidity, above dew point (in operation and storage)</td>
</tr>
</tbody>
</table>

### Design, enclosure

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Specification</th>
</tr>
</thead>
<tbody>
<tr>
<td>Degree of protection</td>
<td>IP20 according to EN 60529</td>
</tr>
<tr>
<td>Dimensions</td>
<td>177 x 440 x 380 mm</td>
</tr>
<tr>
<td>Weight</td>
<td>Approx. 13 kg</td>
</tr>
<tr>
<td>Mounting</td>
<td>Horizontal</td>
</tr>
</tbody>
</table>

### General information

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Specification</th>
</tr>
</thead>
<tbody>
<tr>
<td>Concentration units</td>
<td>ppmv, Vol%, mg/Nm³</td>
</tr>
<tr>
<td>Display</td>
<td>Digital concentration display (5 digits with floating decimal point)</td>
</tr>
<tr>
<td>Laser protection class</td>
<td>Class 1, safe to the eye</td>
</tr>
<tr>
<td>Certificates</td>
<td>CE marking, TÜV, MCERTS</td>
</tr>
</tbody>
</table>

### Certificates

- CE marking
- TÜV
- MCERTS
### Selection and ordering data

**LDS 6 in-situ gas analyzer**

19" rack unit for installation in cabinets

<table>
<thead>
<tr>
<th>Measured component</th>
<th>Possible with application letter of the respective channel</th>
</tr>
</thead>
<tbody>
<tr>
<td>O₂</td>
<td>B, C, P</td>
</tr>
<tr>
<td>O₂/Temp</td>
<td>B</td>
</tr>
<tr>
<td>NH₃</td>
<td>A, E, F, T</td>
</tr>
<tr>
<td>NH₃/H₂O</td>
<td>A, E, F, T</td>
</tr>
<tr>
<td>HCl</td>
<td>A, H</td>
</tr>
<tr>
<td>HCl/H₂O</td>
<td>A, H</td>
</tr>
<tr>
<td>HF</td>
<td>A, H</td>
</tr>
<tr>
<td>HF/H₂O</td>
<td>A, H</td>
</tr>
<tr>
<td>CO</td>
<td>C</td>
</tr>
<tr>
<td>CO/CO₂</td>
<td>D</td>
</tr>
<tr>
<td>CO₂</td>
<td>A</td>
</tr>
<tr>
<td>H₂O</td>
<td>A, T</td>
</tr>
</tbody>
</table>

**Explosion protection**

Without, not suitable for connection to Ex sensors

Without, suitable for connection to Ex sensors in accordance with ATEX II 1G Ex ia IIC T4, ATEX II 1D Ex iaD 20 IP65 T135 °C

**Application letter of measured component channel 1**

<table>
<thead>
<tr>
<th>Application letter</th>
<th>Application examples channel 1</th>
</tr>
</thead>
<tbody>
<tr>
<td>A</td>
<td>Emission monitoring, non-certified</td>
</tr>
<tr>
<td>B</td>
<td>Emission monitoring, combustion optimization</td>
</tr>
<tr>
<td>C</td>
<td>Safety monitoring with appropriate plant concept</td>
</tr>
<tr>
<td>D</td>
<td>Process control</td>
</tr>
<tr>
<td>E</td>
<td>SNCR-DeNOx</td>
</tr>
<tr>
<td>F</td>
<td>SCR-DeNOx</td>
</tr>
<tr>
<td>H</td>
<td>Filter optimization</td>
</tr>
<tr>
<td>P</td>
<td>Process control (high pressure)</td>
</tr>
<tr>
<td>T</td>
<td>Emission monitoring, certified according to 17th BImSchV and MCerts, in combination with measured component variants C, D, E, F, M</td>
</tr>
</tbody>
</table>

**Application letter of measured component channel 2**

<table>
<thead>
<tr>
<th>Application letter</th>
<th>Application examples channel 2</th>
</tr>
</thead>
<tbody>
<tr>
<td>X</td>
<td>Channel 2 not used</td>
</tr>
<tr>
<td>A</td>
<td>Emission monitoring</td>
</tr>
<tr>
<td>B</td>
<td>Combustion optimization</td>
</tr>
<tr>
<td>C</td>
<td>Safety monitoring with appropriate plant concept</td>
</tr>
<tr>
<td>D</td>
<td>Process control</td>
</tr>
<tr>
<td>E</td>
<td>SNCR-DeNOx</td>
</tr>
<tr>
<td>F</td>
<td>SCR-DeNOx</td>
</tr>
<tr>
<td>H</td>
<td>Filter optimization</td>
</tr>
<tr>
<td>P</td>
<td>Process control (high pressure)</td>
</tr>
<tr>
<td>T</td>
<td>Emission monitoring, certified according to 17th BImSchV and MCerts, in combination with measured component variants C, D, E, F, M</td>
</tr>
</tbody>
</table>

---

A) Subject to export regulations AL: 2B351A, ECCN: EAR99

C) Subject to export regulations AL: N, ECCN: EAR99

1) The examples shown represent possible applications where appropriately configured LDS 6 solutions can be used. The user is responsible for the prevailing conditions (plant concept (possibly redundant), application of appropriate components required in addition, compliance with possible directives, etc.).
The examples shown represent possible applications where appropriately configured LDS 6 solutions can be used. The user is responsible for the prevailing conditions (plant concept (possibly redundant), application of appropriate components required in addition, compliance with possible directives, etc.).
Dimensional drawings

LDS 6, 19” central unit, dimensions in mm
Continuous Gas Analyzers, in-situ

LDS 6

19” central unit

Schematics

Pin assignments

SUB-D connector 15F

SUB-D connector D 25F

Analog outputs: floating (also against each other), \( R < 750 \Omega \)

Pressure compensation

Temper. compensation

Non-floating analog inputs (50 \( \Omega \))

Floating via opto-isolator

"0" = 0 V (0 ... 4.5 V)

"1" = 24 V (13 ... 33 V)

Floating via optocoupler

"0" = 0 V (0 ... 4.5 V)

"1" = 24 V (13 ... 33 V)

Relay is current-free for relay contact arrangement shown

Contact load max. 24 V/1 A, AC/DC
Optical and electrical connections

25-pin connector:
Binary inputs and relay outputs

15-pin connector:
Binary inputs and analog inputs/outputs

Power supply and fuses

Hybrid cable support

E2000 single mode opto-connector

SMA multimode opto-connector

24 V DC sensor supply

Ethernet converter RJ-45

LDS 6, three-channel 19" central unit, optical and electrical connections
More information

The following table lists the measuring conditions for standard applications. The listed values for the measuring range and detection limit (DL) are only approximate values. The exact values at the respective measuring point depend on the totality of all influencing variables and can be determined by Siemens for the specific case.

Please note that the values for the detection limit and the maximum measuring range refer to an optical path of 1 m. Longer path lengths will improve the detection limit, but not linearly. Due to limiting effects such as dust load. The maximum applicable measuring ranges can only be used if permitted by the process conditions such as dust load.

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<tr>
<th>Standard application</th>
<th>Effective optical path length: 0.3 … 12 m</th>
<th>Dust load&lt;sup&gt;3)&lt;/sup&gt;: &lt; 50 g/Nm&lt;sup&gt;3&lt;/sup&gt;</th>
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</thead>
</table>

<table>
<thead>
<tr>
<th>Gas 1</th>
<th>Gas 2</th>
<th>Gas code</th>
<th>Appl. code</th>
<th>Process gas temperature T&lt;sub&gt;min&lt;/sub&gt; ... T&lt;sub&gt;max&lt;/sub&gt;</th>
<th>Process gas pressure p&lt;sub&gt;min&lt;/sub&gt; ... p&lt;sub&gt;max&lt;/sub&gt;</th>
<th>Min. measuring range (with 1 m eff. opt. path length)</th>
<th>Max. measuring range (also dependent on eff. opt. path length: see following column)</th>
<th>(Max. measuring range x path length)</th>
<th>(DL x path length) under standard conditions&lt;sup&gt;1)&lt;/sup&gt;</th>
<th>Accuracy&lt;sup&gt;4)&lt;/sup&gt;</th>
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</thead>
<tbody>
<tr>
<td>O&lt;sub&gt;2&lt;/sub&gt;</td>
<td></td>
<td></td>
<td></td>
<td>A</td>
<td>B</td>
<td>600 ... 1 200 °C</td>
<td>950 ... 1 050 hPa</td>
<td>0 ... 15 vol%</td>
<td>0 ... 100 vol%</td>
<td>240 vol%*m&lt;sup&gt;-1&lt;/sup&gt;</td>
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<tr>
<td></td>
<td></td>
<td></td>
<td></td>
<td>C</td>
<td>0 ... 600 °C</td>
<td>950 ... 1 050 hPa</td>
<td>0 ... 5 vol%</td>
<td>0 ... 100 vol%</td>
<td>260 vol%*m&lt;sup&gt;-1&lt;/sup&gt;</td>
<td>0.1 vol%*m&lt;sup&gt;-1&lt;/sup&gt; at 600 °C</td>
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<tr>
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<td>P</td>
<td>0 ... 200 °C</td>
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<td>0 ... 5 vol%</td>
<td>0 ... 100 vol%</td>
<td>260 vol%*m&lt;sup&gt;-1&lt;/sup&gt;</td>
<td>0.1 vol%*m&lt;sup&gt;-1&lt;/sup&gt; at 600 °C</td>
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<tr>
<td>O&lt;sub&gt;2&lt;/sub&gt;</td>
<td>Temp</td>
<td></td>
<td></td>
<td>B</td>
<td>600 ... 1 200 °C</td>
<td>950 ... 1 050 hPa</td>
<td>0 ... 35 vol%</td>
<td>0 ... 100 vol%</td>
<td>240 vol%*m&lt;sup&gt;-1&lt;/sup&gt;</td>
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<td>A</td>
<td>0 ... 150 °C</td>
<td>950 ... 1 050 hPa</td>
<td>0 ... 25 ppmv</td>
<td>0 ... 500 ppmv</td>
<td>2 500 ppmv&lt;sup&gt;-1&lt;/sup&gt;</td>
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<td>950 ... 1 050 hPa</td>
<td>0 ... 25 ppmv</td>
<td>0 ... 500 ppmv</td>
<td>2 500 ppmv&lt;sup&gt;-1&lt;/sup&gt;</td>
<td>0.5 ppmv&lt;sup&gt;-1&lt;/sup&gt; at 15 vol%</td>
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<tr>
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<td>E</td>
<td>250 ... 350 °C</td>
<td>950 ... 1 050 hPa</td>
<td>0 ... 45 ppmv</td>
<td>0 ... 500 ppmv</td>
<td>2 500 ppmv&lt;sup&gt;-1&lt;/sup&gt;</td>
<td>0.9 ppmv&lt;sup&gt;-1&lt;/sup&gt; at 250 °C</td>
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<tr>
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<td>F</td>
<td>300 ... 400 °C</td>
<td>950 ... 1 050 hPa</td>
<td>0 ... 50 ppmv</td>
<td>0 ... 500 ppmv</td>
<td>2 500 ppmv&lt;sup&gt;-1&lt;/sup&gt;</td>
<td>1 ppmv&lt;sup&gt;-1&lt;/sup&gt; at 300 °C</td>
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<td>0 ... 150 °C</td>
<td>950 ... 1 050 hPa</td>
<td>0 ... 25 ppmv</td>
<td>0 ... 100 ppmv</td>
<td>1 200 ppmv&lt;sup&gt;-1&lt;/sup&gt;</td>
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<td>1 ppmv&lt;sup&gt;-1&lt;/sup&gt; at 300 °C</td>
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<td>A</td>
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<td>950 ... 1 050 hPa</td>
<td>0 ... 30 ppmv</td>
<td>0 ... 6 000 ppmv</td>
<td>1 200 ppmv&lt;sup&gt;-1&lt;/sup&gt;</td>
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<tr>
<td></td>
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<td>T</td>
<td>120 ... 210 °C</td>
<td>950 ... 1 050 hPa</td>
<td>0 ... 10 ppmv</td>
<td>0 ... 60 ppmv</td>
<td>720 ppmv&lt;sup&gt;-1&lt;/sup&gt;</td>
<td>2.2 ppmv&lt;sup&gt;-1&lt;/sup&gt; at 15 % H&lt;sub&gt;2&lt;/sub&gt;O, 55 °C</td>
</tr>
<tr>
<td></td>
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<td></td>
<td></td>
<td>H</td>
<td>150 ... 250 °C</td>
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<td>0 ... 6 000 ppmv</td>
<td>1 200 ppmv&lt;sup&gt;-1&lt;/sup&gt;</td>
<td>1.0 ppmv&lt;sup&gt;-1&lt;/sup&gt; at 150 °C</td>
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<td>0 ... 100 ppmv</td>
<td>1 200 ppmv&lt;sup&gt;-1&lt;/sup&gt;</td>
<td>1.0 ppmv&lt;sup&gt;-1&lt;/sup&gt; at 150 °C</td>
</tr>
</tbody>
</table>

<sup>1)</sup> under standard conditions

<sup>2)</sup> without cross-interference of other gases

<sup>3)</sup> Dust load < 50 g/Nm<sup>3</sup>

<sup>4)</sup> Accuracy

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### Standard application

**Effective optical path length:** 0.3 ... 12 m

**Dust load:** \(< 50 \text{ g/Nm}^3\)

### Effective optical path length

<table>
<thead>
<tr>
<th>Standard application</th>
<th>Min. measuring range (with 1 m eff. opt. path length)</th>
<th>Max. measuring range (usually also dependent on eff. opt. path length: see following column)</th>
<th>(Max. measuring range x path length)</th>
<th>(DL x path length) under standard conditions</th>
<th>Accuracy</th>
<th>Purging gas mode</th>
<th>Purging gas medium</th>
</tr>
</thead>
<tbody>
<tr>
<td><strong>O₂</strong></td>
<td></td>
<td><strong>Min. measuring range</strong> <em>path length:</em></td>
<td><strong>Max. measuring range</strong> <em>path length:</em></td>
<td><strong>Accuracy</strong></td>
<td><strong>Purging gas mode</strong></td>
<td><strong>Purging gas medium</strong></td>
<td></td>
</tr>
<tr>
<td><strong>NH₃</strong></td>
<td></td>
<td><strong>Min. measuring range</strong> <em>path length:</em></td>
<td><strong>Max. measuring range</strong> <em>path length:</em></td>
<td><strong>Accuracy</strong></td>
<td><strong>Purging gas mode</strong></td>
<td><strong>Purging gas medium</strong></td>
<td></td>
</tr>
<tr>
<td><strong>H₂O</strong></td>
<td></td>
<td><strong>Min. measuring range</strong> <em>path length:</em></td>
<td><strong>Max. measuring range</strong> <em>path length:</em></td>
<td><strong>Accuracy</strong></td>
<td><strong>Purging gas mode</strong></td>
<td><strong>Purging gas medium</strong></td>
<td></td>
</tr>
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<td><strong>HCl</strong></td>
<td></td>
<td><strong>Min. measuring range</strong> <em>path length:</em></td>
<td><strong>Max. measuring range</strong> <em>path length:</em></td>
<td><strong>Accuracy</strong></td>
<td><strong>Purging gas mode</strong></td>
<td><strong>Purging gas medium</strong></td>
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<tr>
<td><strong>H₂O</strong></td>
<td></td>
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<td><strong>Max. measuring range</strong> <em>path length:</em></td>
<td><strong>Accuracy</strong></td>
<td><strong>Purging gas mode</strong></td>
<td><strong>Purging gas medium</strong></td>
<td></td>
</tr>
</tbody>
</table>

#### Purging gas mode

- E: Oxygen
- F: Nitrogen
- G: Air
- H: Steam, Air, and N₂

#### Purging gas medium

- Steam + Air, N₂

### Table

<table>
<thead>
<tr>
<th>Gas 1</th>
<th>Gas 2</th>
<th>Gas code</th>
<th>Application code</th>
<th>Gas code</th>
<th>Application code</th>
<th>Gas code</th>
<th>Application code</th>
<th>Standard</th>
<th>Optional</th>
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<tbody>
<tr>
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<td>B</td>
<td>E, F, G, H</td>
<td>Steam + air, N₂</td>
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<tr>
<td>O₂ Temp</td>
<td>B</td>
<td>B</td>
<td>600 ... 1 200 °C</td>
<td>F, H</td>
<td>Steam, N₂</td>
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<td>C, G, Air</td>
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<td>NH₃ H₂O</td>
<td>D</td>
<td>A</td>
<td>0 ... 5 vol%</td>
<td>0 ... 30 vol%</td>
<td>240 vol%*m</td>
<td>0.1 vol%*m</td>
<td>0.1 vol%*m</td>
<td>5%</td>
<td>C</td>
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<tr>
<td>T</td>
<td>0 ... 5 vol%</td>
<td>0 ... 30 vol%</td>
<td>240 vol%*m</td>
<td>0.1 vol%*m</td>
<td>0.1 vol%*m</td>
<td>5%</td>
<td>C</td>
<td>G</td>
<td>Air</td>
</tr>
<tr>
<td>E</td>
<td>0 ... 5 vol%</td>
<td>0 ... 30 vol%</td>
<td>240 vol%*m</td>
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<td>E</td>
<td>G</td>
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<tr>
<td>F</td>
<td>0 ... 5 vol%</td>
<td>0 ... 30 vol%</td>
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<td>0.1 vol%*m</td>
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<td>E</td>
<td>G</td>
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<tr>
<td>HCl</td>
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<td>0 ... 5 vol%</td>
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<td>360 vol%*m</td>
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<td>5%</td>
<td>C</td>
<td>G</td>
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<td>H</td>
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<td>0.1 vol%*m</td>
<td>5%</td>
<td>E</td>
<td>G</td>
<td>Air</td>
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**Continuous Gas Analyzers, in-situ**

**LDS 6**

**19” central unit**

<table>
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<tr>
<th>Standard application</th>
<th>Effective optical path length: 0.3 ... 12 m</th>
<th>Dust load: &lt; 50 g/Nm³</th>
</tr>
</thead>
</table>

<table>
<thead>
<tr>
<th>Process gas temperature $T_{\text{min}} ... T_{\text{max}}$</th>
<th>Process gas pressure $p_{\text{min}} ... p_{\text{max}}$</th>
<th>Min. measuring range (with 1 m eff. opt. path length)</th>
<th>Max. measuring range (also dependent on eff. opt. path length: see following column)</th>
<th>(Max. measuring range x path length)</th>
<th>Under standard conditions</th>
<th>Accuracy</th>
</tr>
</thead>
<tbody>
<tr>
<td>$0 \ldots 150 ^\circ \text{C}$</td>
<td>$950 \ldots 1050 \text{hPa}$</td>
<td>$0 \ldots 5 \text{ppmv}$</td>
<td>$1500 \text{ppmv}$</td>
<td>$200 \text{ppmv}^* \text{m}$</td>
<td>$0.1 \text{ppmv}^* \text{m}$</td>
<td>$0.6 \text{ppmv}^* \text{m}$ at $15 \text{vol}% \text{H}_2\text{O}$, 55 °C</td>
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<tr>
<td>HF</td>
<td>G</td>
<td>A</td>
<td>$0 \ldots 150 ^\circ \text{C}$</td>
<td>$950 \ldots 1050 \text{hPa}$</td>
<td>$0 \ldots 5 \text{ppmv}$</td>
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<td>150 ... 250 ^\circ \text{C}</td>
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<td>$200 \text{ppmv}^* \text{m}$</td>
<td>$0.11 \text{ppmv}^* \text{m}$ at 150 °C</td>
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<td>H</td>
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<tr>
<td>CO</td>
<td>J</td>
<td>C</td>
<td>$0 \ldots 600 ^\circ \text{C}$</td>
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<td>$0 \ldots 1.5 \text{vol}%$</td>
<td>$100 \text{vol}%$</td>
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<tr>
<td>CO</td>
<td>K</td>
<td>D</td>
<td>$0 \ldots 400 ^\circ \text{C}$</td>
<td>$800 \ldots 1400 \text{hPa}$</td>
<td>$0 \ldots 3.0 \text{vol}%$</td>
<td>$100 \text{vol}%$</td>
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<td>$100 \text{vol}%$</td>
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<td>M</td>
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<td>$0 \ldots 5 \text{vol}%$</td>
<td>$30 \text{vol}%$</td>
</tr>
<tr>
<td>CO</td>
<td>T</td>
<td>0 ... 150 °C</td>
<td>$950 \ldots 1050 \text{hPa}$</td>
<td>$0 \ldots 5 \text{vol}%$</td>
<td>$30 \text{vol}%$</td>
<td>$240 \text{vol}%^* \text{m}$</td>
</tr>
</tbody>
</table>

1) At 20 °C, 1 013 hPa
2) If the smallest permissible process gas temperature of the application is $T_{\text{min}} > 20 ^\circ \text{C}$, the detection limit refers to $T_{\text{min}}$ and standard pressure (1 013 hPa)
3) At 0.3 m effective optical path length, average diameter of the dust particles: 15 µm, specific weight of the dust particles: 650 kg/m³
4) At least: Detection limit
5) Up to 200 °C, 5 % above this
6) Up to 60 vol% CO or up to 60 vol% CO₂. Higher CO or CO₂ concentrations on request.
<table>
<thead>
<tr>
<th>Gas code</th>
<th>Gas code</th>
<th>Appl. code</th>
<th>Gas 2</th>
<th>Gas 2</th>
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<td>C</td>
<td>G</td>
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<td>E</td>
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<tr>
<td>HF</td>
<td>H</td>
<td>A</td>
<td>0 ... 5 vol%</td>
<td>0 ... 30 vol%</td>
<td>360 vol%*m</td>
<td>0.1 vol%*m</td>
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<td>5 %</td>
<td>C</td>
<td>G</td>
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<tr>
<td></td>
<td>H</td>
<td></td>
<td>0 ... 5 vol%</td>
<td>0 ... 30 vol%</td>
<td>360 vol%*m</td>
<td>300 ppmv*m at 200 °C</td>
<td>300 ppmv*m at 200 °C</td>
<td>5 %</td>
<td>E</td>
<td>G</td>
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<tr>
<td>CO</td>
<td>J</td>
<td>C</td>
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<td>E</td>
<td>G</td>
</tr>
<tr>
<td>CO</td>
<td>K</td>
<td>D</td>
<td>0 ... 7.5 vol%</td>
<td>0 ... 100 vol%</td>
<td>75 vol%*m</td>
<td>0.5 vol%*m</td>
<td>1 500 ppmv*m at 50 vol% CO, 20 °C</td>
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<td>G</td>
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<td></td>
<td></td>
<td>C</td>
<td>G</td>
</tr>
</tbody>
</table>

1) At 20 °C, 1 013 hPa
2) If the smallest permissible process gas temperature of the application is Tmin > 20 °C, the detection limit refers to Tmin and standard pressure (1 013 hPa)
3) At 0.3 m optical path length, average diameter of the dust particles: 15 µm, specific weight of the dust particles: 650 kg/m³
4) At least: Detection limit
5) At 600 °C and at least 5 vol%*m O₂ concentration: Resolution = 15 °C, at 1 000 °C and at least 5 vol%*m O₂ concentration: Resolution = 25 °C
6) Depends on temperature (higher values at higher temperatures)
Continuous Gas Analyzers, in-situ

Cross-duct sensor CD 6

Overview

Cross-duct sensors CD 6 and cables for non-Ex applications

The standard cross-duct sensor consists of a transmitter unit and a detector unit with the same dimensions. The transmitter unit provides a connector for the fiber-optic cable. The laser light is transmitted through this cable. The receiver unit contains a photodetector and an electronics PCB, and is connected to the detector unit by a sensor cable.

The sensors are mounted onto flanges. The easiest way to avoid condensation and dust deposits on the sensor windows is to purge them, e.g. with instrument air. Purging must be selected depending on the application. The cross-duct sensors can therefore be configured for the respective situation. The application reference table provides recommendations for suitable purging with standard applications.

If a component is to be measured which is also present in measurable quantities in the purging medium - such as oxygen or moisture - it is necessary to use purging gases such as nitrogen, superheated process steam or similar. In such cases it is usually also necessary to purge the sensor heads, since the ambient air must also be displaced here out of the laser beam path. A differentiation is therefore made between purging on the process side and purging on the sensor side.

Note

For measurement of O₂ at gas temperatures above 600 °C, it may also be possible to tolerate air as the purging medium since its influence on the measurement can be compensated. In contrast, the combination O₂/temperature always requires O₂-free purging.

Applications with oxygen (high-pressure)

For oxygen measurements with a higher process gas pressure (1 to 5 bar), the sensor CD 6 can be used together with a suitable window flange as the process connection. This window flange is also available in the standard sizes DN 65/PN 6, DN 80/PN 16 or ANSI 4”/150 lbs. The optical surface to the process is made of borosilicate glass. Flanges can be equipped with window purging, but without purging tubes. Possible purge modes for the window flanges are "A-C" (no purging or moderate purging on the process side). Window flanges are tested for leakage before delivery using overpressure, and show leakage rates of less than 10^-5 mbar ⋅ l/s.

For ordering this application, the MLFB code of the central unit with the application code "P" must be selected. The process interface suitable for the sensors can be chosen by selection of the corresponding code in the 6th configurable position of the MLFB number.

The most important sensor purging configurations are presented below:

Purging on the process side with moderate flow

Is selected e.g. for pure gas applications, emission monitoring, inerting monitoring. The purging gas flow can be adjusted between 0 and approx. 120 l/min at each sensor head using a needle valve (included in delivery).

Moderate purging on process side

Purging on the process side with increased flow

Through omission of needle valve. This type of purging is selected in crude gas applications with higher concentrations of particles and/or condensation as well as in non-purified flue gases in combustion plants. The purging gas flow is typically set between 200 and 500 l/min on each sensor head depending on the input pressure of the purging medium.

Increased purging on process side

Purging on the process side with high flow

Through use of air blower or dry process steam. Connectors with hose adapters are included in the delivery. An additional Swagelok adapter must be ordered if a high flow of steam or instrument air purging is required (option A27). This type of purging is selected in crude gas applications with very high concentrations of particles and/or condensation such as in the furnaces of combustion plants. If instrument air is not available, an air blower is also an alternative for purging in applications with lower demands. On the process side, dry steam can be used as the inert purging gas instead of nitrogen. The purging gas flow is automatically set between 500 and <1 000 l/min on each sensor head depending on the purging air blower or the steam pressure.

Increased purging on process side, with hose connection adapter
Purging on sensor side

Can be combined with any purging mode on the process side, and is always selected if the ambient air must never have an influence on the measurement. The volumes within the sensor head are then continuously purged with an O₂-free gas. Allowed purging gases are nitrogen or carbon dioxide. The flow of purging gas required in this case is approx. 1 to 6 l/min and is set using a needle valve (included in delivery). The combination shown here of purging with superheated process steam on the process side and with nitrogen from a compressed gas bottle on the sensor side may satisfy the necessity for O₂-free purging e.g. also in combustion plants with boilers without own nitrogen network.

Note

With purging on the process side, it may be necessary to use non-return valves to ensure no process gas can enter the purging gas line in the event of failure of the purging gas supply. This applies especially in the case of cascaded process and sensor purging where there is otherwise the danger that, for example, corrosive process gases could enter the sensor enclosure.

Sensor configuration with high purging on process side, with 6 mm joint for use with steam, and with N₂ purging on the sensor side

The purging media used on the process side flow through purging gas tubes into the process gas stream. The tubes extend a few centimeters into the process area, and usually provide a flow from the side. This results in a wedge being generated in the inlet zone of the purging gas. The effective measuring path in the process gas is therefore well-defined as the distance between the ends of the two purging gas inlet tubes.

Cross-duct sensor CD 6: Options and accessories

Sensor alignment kit

Includes a battery-operated visible light source, a centering aid with crosshair, and two hook spanners for opening the optics tube of the sensors.

Please note: the sensor alignment kit is not explosion protected.
Continuous Gas Analyzers, in-situ

LDS 6

Cross-duct sensor CD 6

Purging air blower

Two purging air blowers are required to purge the sensor heads. Both 230 V AC and 115 V AC versions can be ordered.

Flow cell (available on special application)

For implementation of measuring configurations with bypass mode. The cell consists of a stainless steel tube whose internal surfaces are coated with PTFE to minimize surface effects. With an effective measuring path of 1 m, the inner volume is only 1.2 l, and fast gas displacement times can therefore be achieved. The flow of sample gas can be from the ends or from the center of the tube, since appropriate 6 mm joints are present here. The flow cell can be ordered in four configurations:

- Unheated, including assembly for wall mounting
- Unheated, including assembly for wall mounting and a 19" housing with an air jet pump with a delivery rate of max. 30 l/min
- As above, but can be heated up to approx. 200 °C
- As above, but can be heated up to approx. 200 °C and mounted on a rack with wheels and integrated 19" frame

Optical bandpass filter

Serves to protect the light-sensitive detector in the receiver unit of the sensor from saturation by IR background radiation. Is used with measurements in very hot process gases (T > 1000 °C) or with unavoidable appearances of flames in the measurement path.
Continuous Gas Analyzers, in-situ

Cross-duct sensor CD 6

Technical specifications

Cross-duct sensor CD 6

General information

Design
Transmitter and detector units, connected by a sensor cable

Materials
Stainless steel

Installation
Horizontally to the optical axis, perpendicular or parallel to the gas flow

Laser protection class
Class 1, safe to the eye

Explosion protection
Optional, acc. to ATEX II 1 G Ex ia IIC T4, ATEX II 1 D Ex iaD 20 IP65 T135 °C

An defined leak rate can only be guaranteed when using high-pressure window flanges. Otherwise it may be necessary for the owner to carry out an evaluation in accordance with ATEX (DEMKO 06 ATEX 139648X [17]).

Accessories

Purging
Nitrogen is permissible as the purging gas for the sensor side. Nitrogen, steam, air and gases which are not subject to the pressure equipment directive Cat. 2 are permissible as purging gases for the process side.

Purging with instrument air, N₂

- Pressure at purging inlet
  2 000 ... 8 000 hPa
- Max. overpressure in the sensor
  < 500 hPa
- Quality
  - Instrument air
  - Nitrogen

Free of oil and water

Purity better than 99.7 %. For oxygen measurements, and an O₂ content < 0.01 % in the purging gas (optical path length ≥ 1 m, min. 5 % oxygen in the process gas)

- Maximum flow rate
  500 l/min
- Dew point
  Benchmark: < -10 °C, condensation on the optics must be avoided

Blower purging

- Maximum counter pressure
  40 hPa
- Maximum flow rate
  850 l/min
- Power consumption
  370 W
- Degree of protection (fan)
  IP54, cover required to protect against rain

Steam purging

- Steam conditioning
  Overheated
- Maximum temperature
  240 °C
- Minimum pressure
  > 4 000 hPa
- Maximum pressure
  16 000 hPa, refers to a volume flow of approx. 1 100 l/min

Hybrid and sensor cables

General information

Two optical fibers and two twisted copper wires in one cable for 24 V DC. Single-mode optical fiber configured at both ends with E2000 angle connectors. Multimode optical fiber configured at both ends with SMA connectors.

Cable sheath

Oil-resistant polyurethane

General information

Configuration hybrid cable

Dust load

The influence of dust is very complex and depends on the path length and particle size. The optical damping increases exponentially at longer path lengths. Smaller particles also have a large influence on the optical damping. With high dust load, long path length and small particle size, the technical support at Siemens should be consulted.
## Continuous Gas Analyzers, in-situ

### Cross-duct sensor CD 6

<table>
<thead>
<tr>
<th>Selection and ordering data</th>
<th>Order No.</th>
</tr>
</thead>
<tbody>
<tr>
<td>LDS 6 in-situ gas analyzer</td>
<td>7MB6122-2012</td>
</tr>
</tbody>
</table>

### Explosion protection

- Without: 0
- According to ATEX II 1 G Ex ia IIC T4, ATEX II 1 D Ex iaD 20 IP65 T135 °C: 1

### Sensor type

- Standard cross-duct sensor
-Measured component: O<sub>2</sub>
- All gases except O<sub>2</sub>

### Purging, process side

- Without purging
- Instrument air or N<sub>2</sub>
  - Reduced flow: 0 ... 120 l/min
  - incl. needle valve, 6 mm Swagelok
- Air or N<sub>2</sub>
  - Increased flow: 200 ... 500 l/min
  - incl. needle valve, 6 mm Swagelok
  - Air, fan or steam; high flow: > 500 l/min
  - incl. 1½” hose adapter

### Purging tubes, material

- No purging tubes: 0
- Stainless steel, EN 1.4432/316L: 1

### Purging tubes, length

- No purging tubes: 0
- 400 mm: 1
- 800 mm: 2
- 1 200 mm: 3
- 75 mm, e.g. for engine test rigs: 4

### Process connection

- Stainless steel flange (EN 1.4404/316L), dimensions acc. to DN 65/PN 6: 0
- Stainless steel flange (EN 1.4404/316L), dimensions acc. to ANSI 4”/150 lbs: 1
- Stainless steel flange (EN 1.4404/316L), dimensions acc. to DN 65/PN 6, including enclosed welding flanges, e.g. for engine test rigs: 2
- Pressure-resistant window flange (EN 1.4404/316L, borosilicate glass), DN 65/PN 6: 3
- Pressure-resistant window flange (EN 1.4404/316L, borosilicate glass), DN 80/PN 16: 4
- Pressure-resistant window flange (EN 1.4404/316L, borosilicate glass), ANSI 4”/150 lbs: 5

### Hybrid cable

- No hybrid cable: X
- Standard length: A
  - 5: B
  - 10: E
  - 25: G
  - 40: H
  - 50: I
- Customized length (specified in complete meters): Z
### Selection and ordering data

<table>
<thead>
<tr>
<th>Order No.</th>
<th>LDS 6 in-situ gas analyzer Pair of sensors (cross-duct sensor)</th>
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#### Sensor connecting cable

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<th>Length [m]</th>
<th>Language-specific length (specified in complete meters)</th>
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<tr>
<td>10</td>
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</tr>
<tr>
<td>25</td>
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</tr>
</tbody>
</table>

#### Language (supplied documentation)

- German: 0
- English: 1
- French: 2
- Spanish: 3
- Italian: 4

### Selection and ordering data

**Additional versions**

- 6 mm Swagelok adapter for purging with steam, purging modes G and H: Add "-Z" to Order No. and specify order code
- Acceptance test certificate 3.1 (leak test) in accordance with EN10204: C12
- Purging tube, special length: M1Y
- Hybrid cable, customized length: P1Y
- Sensor cable, customized length: Q1Y
- TAG label, customized inscription: Y30

**Additional units**

- Purging air blower 230 V: A5E00829151
- Purging air blower 115 V: A5E00829150
- CD 6, sensor alignment kit: A5E00253142
- Optical filter for reducing IR background radiation (flame filter): A5E00534668

D) Subject to export regulations AL: 9I999, ECCN: N
Continuous Gas Analyzers, in-situ

LDS 6

Cross-duct sensor CD 6

Dimensional drawings

Cross-duct sensor CD 6, moderate purging (instrument air), version according to Order No. 7MB6122-**C1-o***, dimensions in mm

Cross-duct sensor CD 6, increased purging (instrument air), version according to Order No. 7MB6122-**E1-o***, dimensions in mm
Continuous Gas Analyzers, in-situ

Cross-duct sensor CD 6

Cross-duct sensor CD 6, blower purging, version according to Order No. 7MB6122-**G1*-0***, dimensions in mm

Cross-duct sensor CD 6, sensor and process side purging, version according to Order No. 7MB6122-**H1*-0***, dimensions in mm

Process flange (provided by customer)

Test valve

1¼" hose (OD)

Ø 44.5 at 400 length
Ø 54 at 800, 1200 length

Ø 6 mm fitting

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Cross-duct sensor CD 6, purged version according to Order No. 7MB6122-*WC14-2***, dimensions in mm

CD 6 high-pressure sensor for oxygen, dimensions in mm
Selection and ordering data

<table>
<thead>
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Selection and ordering data

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<th>Quantity for 5 years</th>
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<td>2</td>
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<tr>
<td>CD 6, window module, engine test rig, no purging</td>
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<td>2</td>
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<tr>
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</table>

Suggestions for spare parts

More information

LDS 6 does not contain parts subject to wear, but some parts within the sensors might be stressed. For this reason it is recommended for demanding applications to keep window modules and detector electronics on stock (quantities stated per measuring point, i.e. per sensor pair).

For the suitability of different parts (version 1 or version 2) please consult the instrument manual or contact Siemens directly. In general, all new analyzers are compatible with spare parts of version 2.